



**ELECTRONIC COPY**

LG805664956  
Report verification at igi.org



May 30, 2026

IGI Report Number **LG805664956**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **6.52 - 6.56 X 4.08 MM**

**GRADING RESULTS**

Carat Weight **1.07 CARAT**

Color Grade **D**

Clarity Grade **VVS 1**

Cut Grade **IDEAL**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

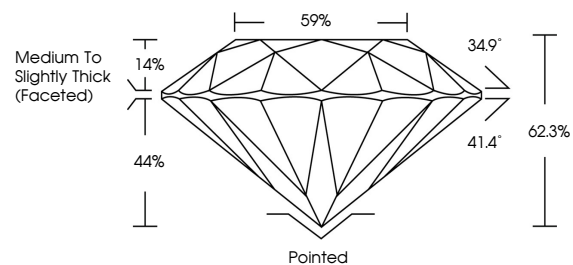
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG805664956**

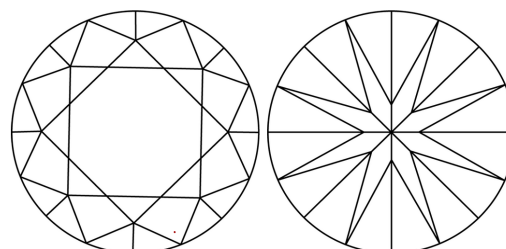
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

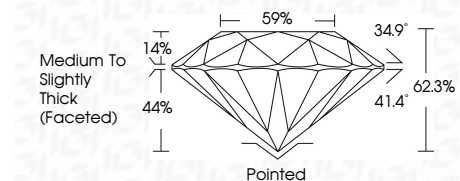
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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ROUND BRILLIANT  
6.52 - 6.56 X 4.08 MM  
Carat Weight 1.07 CARAT  
Color Grade D  
Clarity Grade VVS 1  
Cut Grade IDEAL  
Depth 62.3%  
Table 14%  
Girdle 59%  
Medium To Slightly Thick (Faceted)  
Culet Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscriptions(s) IGI LG805664956  
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